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Hydrodynamic modeling of Laser Ablation

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Outline

- Laser ablation process
- Features to be modeled
- Process modeling highlights:
 - * target heating / melting / vaporization
 - * Knudsen Layer
 - * vapor flow / plume expansion
- Numerical simulations
- conclusion

Laser Ablation

Process of removing material using a pulsed laser beam

Some application areas

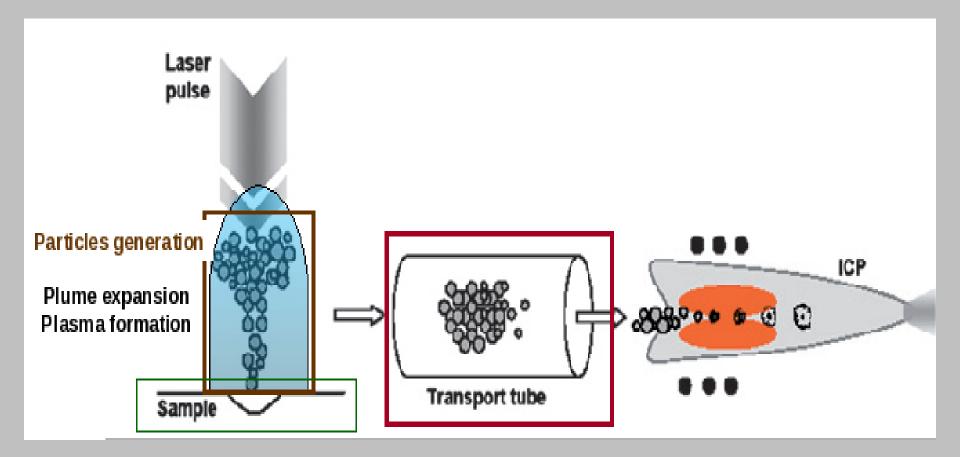
- Cutting, machining,
- Drilling, engraving,
- Bonding, coating,
- Surface cleaning,
- Surgery, dentistry,
- Nanomaterials, ...

- Laser-induced breakdown spectroscopy
- LA Inductively coupled plasma mass spectrometry (ICP-MS)

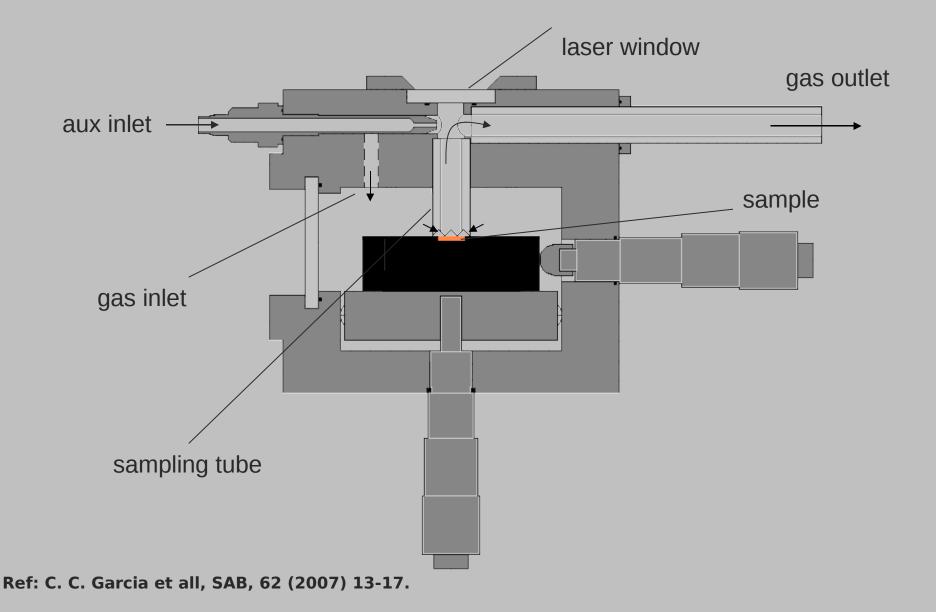
detect trace/ultra-trace elements, as low as 2 parts per 100 billion! Widely used in chemistry,medicine, archaeology, geology, materials sci.

Laser Ablation - Inductively Coupled Plasma Mass Spectrometry (LA-ICP-MS)

Ultrasensitive, multi-element, essentially non-destructive (only ngrams)



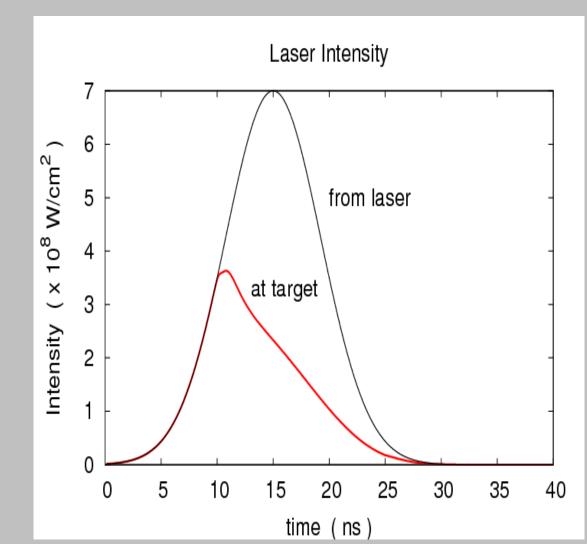
Laser ablation cell



Test conditions

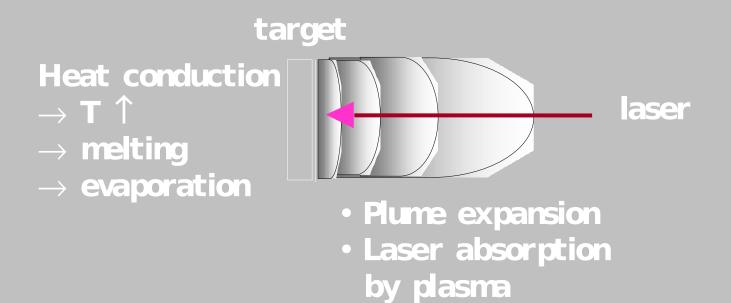
• 8 ns (fwhm) pulse

- $\lambda = 266 \text{ nm}$
- I =10⁹ W/cm²
- Cu target
- 1 atm He gas



Laser intensity

- > solid target heats up, a thin layer melts (Tm=1358K)
- > melt vaporizes at high T, creating a plume of vapor
- > which rapidly expands (and cools somewhat)
- > electrons/ions dissociate creating plasma
- in target : heat conduction / melting / vaporization coupled to electric field (thermionic emission)
- over target: Knudsen transition layer
- in plume/plasma: expansion/recondensation,laser absorption



Features wish list

- seamless treatment of heating / melting / vaporization
- T-dependence: thermophysical properties, reflection & absorption coeffs
- vapor as non-ideal gas, need EoS up to critical T (8000 K)
- spatially non-uniform laser pulse
- thermionic emission, Coulomb explosion: coupling to electric field
- target plume coupling via Knudsen Layer for condensation , subsonic, sonic vaporization
- \bullet determine ${\rm T}_{_{\rm VAD}}$, surface recession velocity
- plume expansion / recondensation, in vacuum or in background gas
- absorption of laser energy in plume / shielding of target
- plasma formation (ions and electrons)
- capture (very) strong shocks via high resolution schemes
- in 2D (axisymmetric) and 3D

Additional Challenges in modeling laser ablation

- Extreme space and time scales
- Extreme gradients: T may rise to thousands of degrees locally
- Extreme variation in thermo-physical properties: k varies by 12 orders of magnitude
- Coupling vaporization to gas flow via Knudsen Layer

 Need extensive thermo-physical data: ρ(T,P), c_p(T), k(T), phase diagram for *solid, liquid, vapor* over the range 300 K to critical T (~8000K)

Target heating / melting / vaporization

described by Heat Conduction equation (for enthalpy):

$$\frac{\partial H}{\partial t} = \nabla \cdot (k \nabla T) + S$$

$$S = I_0(t)(1-R)\alpha exp(-\alpha z)exp(-r^2/a^2)$$
 laser source

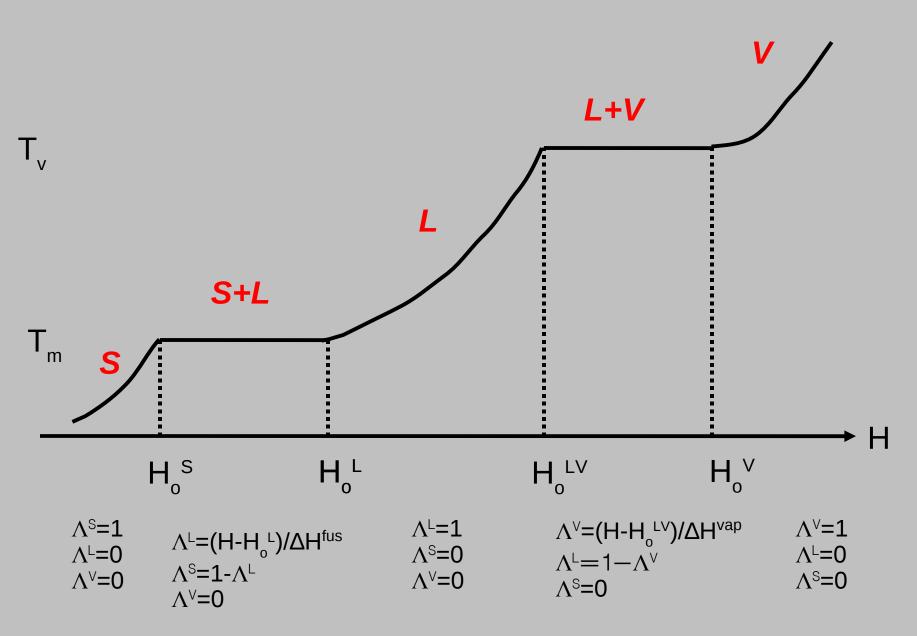
valid throughout the target, irrespectively of phase.

Phases are distinguished by value of enthalpy H via (thermodynamically consistent) *switch values*:

$$H < H_{o}^{S}: solid, \quad H_{o}^{S} < H < H_{o}^{L}: S+L, \quad H_{o}^{L} < H < H_{o}^{LV}: liquid$$
$$H_{o}^{LV} < H < H_{o}^{V}: L+V, \qquad H_{o}^{V} < H: vapor$$

Thermal Equations of State

T and phase fractions from H:



 $H_o^{LV} < H < H_o^{V} : L + V, \qquad H_o^{V} < H : vapor$

 $H < H_o^{S}$: solid, $H_o^{S} < H < H_o^{L}$: S+L, $H_o^{L} < H < H_o^{LV}$: liquid

 $H_o^{\vee}(T_v, P_{ref}) := \rho^{\vee}(T_v, P_{ref}) h_o^{\vee} , \quad h_o^{\vee}(T_v, P_{ref}) := h_o^{\vee}(T_v) + \Delta h^{vap}(T_v, P_{ref}) ,$ $\Delta H^{vap}(T_v, P_{ref}) := H_o^V - H_o^{LV} = (\rho^V - \rho^L)h_o^{LV} + \rho^V \Delta h^{vap}(T_v, P_{ref})$

 $H_o^{LV}(T_v) := H_o^{L} + {}_{Tm} \int^{Tv} C_p^{L}(\tau) d\tau$

Thermal EoS: switch values

$$\Delta H^{\text{fus}}(T_{\text{m}}, P_{\text{ref}}) := H_{\text{o}}^{\text{L}} - H_{\text{o}}^{\text{S}} = (\rho^{\text{L}} - \rho^{\text{S}})h_{\text{o}}^{\text{S}} + \rho^{\text{L}}\Delta h^{\text{fus}}$$

 $H_o^{L} := \rho^{L} h_o^{L} , \quad h_o^{L} := h_o^{S} + \Delta h^{fus}(T_m, P_{ref}) ,$

$$H_o^s := \rho^s h_o^s$$
, $h_o^s := h_{ref}$

Choose P_{ref} =1 atm, h_{ref} , set:

Algorithm in target

Time-explicit Finite Volume discretization

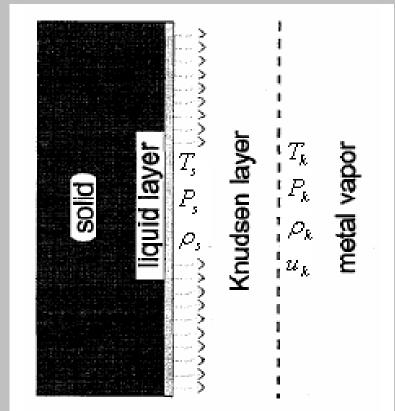
Update H from conservation law

Determine phase fractions and T from EoS

If $\Lambda^{\vee} > 0$, determine $T_{_{vap}}$, $P_{_{sat}}(T_{_{vap}})$ at surface,

and surface recession velocity, via energy and mass conservation and jump conditions across the **Knudsen Layer**

which couple target to plume and yield incoming boundary conditions for fluid dynamics in plume.



Knudsen Layer

Thin transition layer (a few mean free paths) between liquid and vapor where molecules are not in translational equilibrium.
 T, P, ρ undergo jumps governed by local Mach number We use [Gusarov-Smurov, 2005] treatment (messy...)

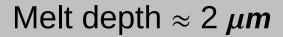
From energy and mass conservation and the KL jump conditions, we determine the following at the "outside" of the KL:

- * *Mach number* (\implies condensation or subsonic or sonic vap)
- * recession velocity of melt surface
- * vaporization T
- * saturation Pressure
- * vapor density
- * *vapor velocity* (\rightarrow inflow BC for CFD in plume)

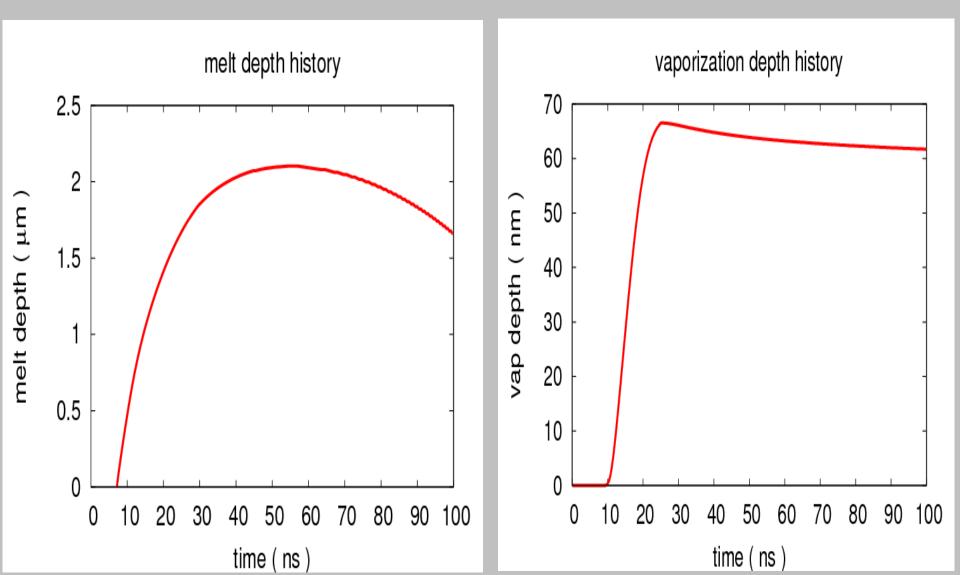
Discretization: Finite Volume, explicit in time **Mesh for 1-D simulation:** $\Delta x = 200 \text{ nm}, \Delta t = 10^{-5} \text{ ns}$ (expanding mesh)

Target melting - vaporization

1-D simulation



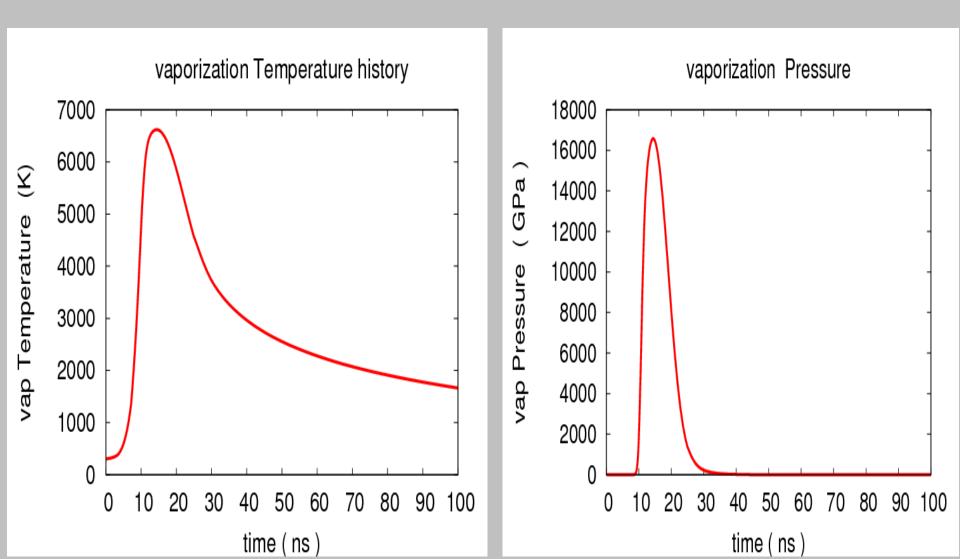
Vaporization depth \approx 70 nm



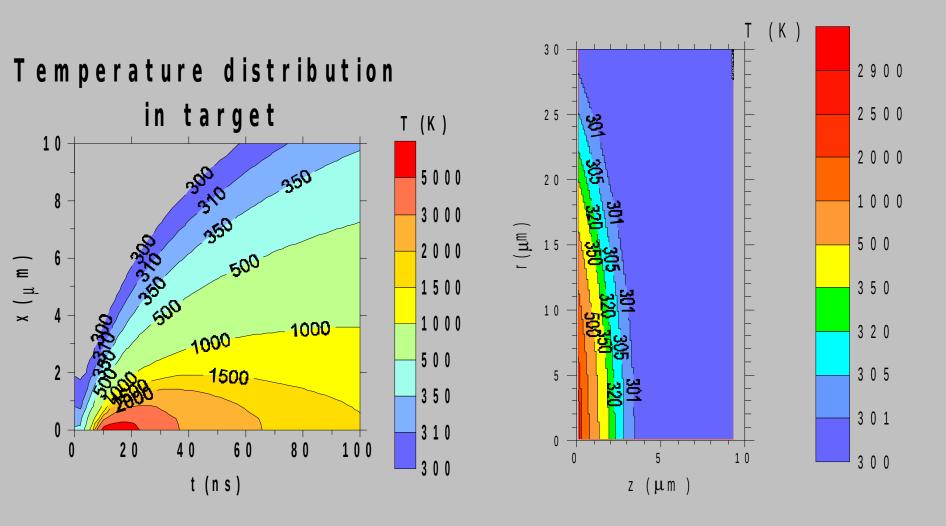
Target vaporization

1-D simulation

peak $T_{vap} \sim 6600 \text{ K}$ at t~15 ns peak $P_{vap} \sim 160 \times 10^6 \text{ atm}$



Target heating



2D, at 10 ns

1D

Expansion of vapor plume in background gas

Conservation laws:

- Mass (species: Cu , He)
- Momentum
- Energy
- Equation of State

Uknowns: ρ_i , \vec{v} , T, P

$$\frac{\partial U}{\partial t} + \nabla \cdot \vec{F} = S$$

$$U = \begin{bmatrix} \rho \\ \rho \vec{v} \\ \rho \epsilon \end{bmatrix} \quad \vec{F} = \begin{bmatrix} \rho \vec{v} \\ \rho \vec{v} \\ \rho \vec{v} + P1 \\ (\rho \epsilon + P) \vec{v} + \vec{q} \end{bmatrix} \quad S = \begin{bmatrix} 0 \\ 0 \\ \Lambda \end{bmatrix}$$

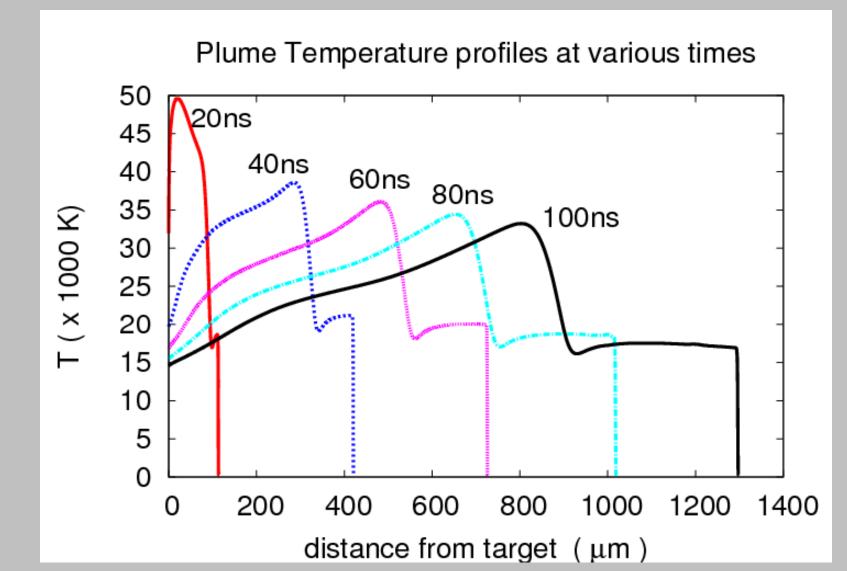
Discretization: Finite Volume, explicit in time **Advection scheme:** 2nd order central (Tadmor) or AUSM+

Mesh for 1-D simulation: $\Delta x = 200 \text{ nm}, \Delta t = 10^{-5} \text{ ns}$ (expanding mesh: starts with 50 nodes, grows to 2500)

Expansion of vapor plume in He gas

1-D simulation

Peak plume **Temperature** ~ 50,000 K !!!



Expansion of vapor plume in He gas

1-D simulation

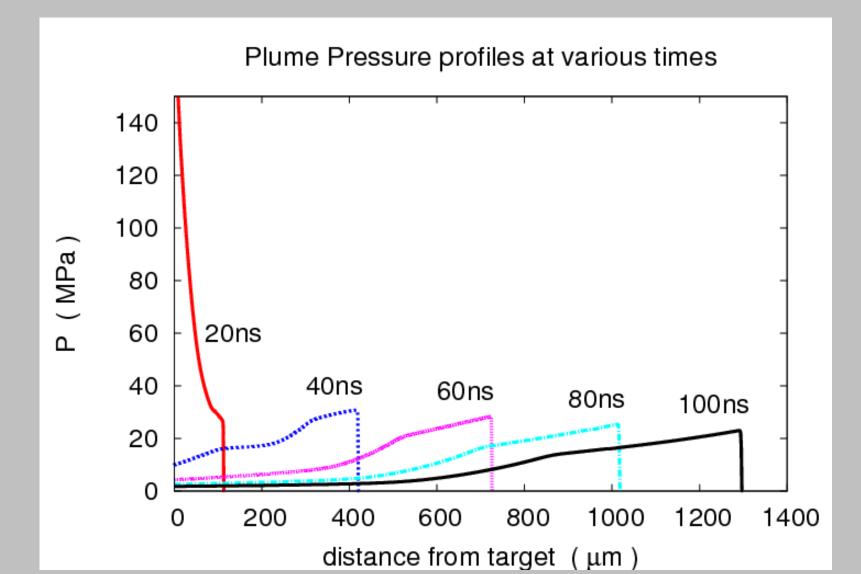
Peak plume velocity ~ 12 km/s !!!

Plume velocity profiles at various times 40ns 20ns 12 60ns 80ns 100ns plume velocity(km/s) 10 8 6 4 2 0 200 400 600 1000 1200 800 1400 0 distance from target (µm)

Expansion of vapor plume in He gas

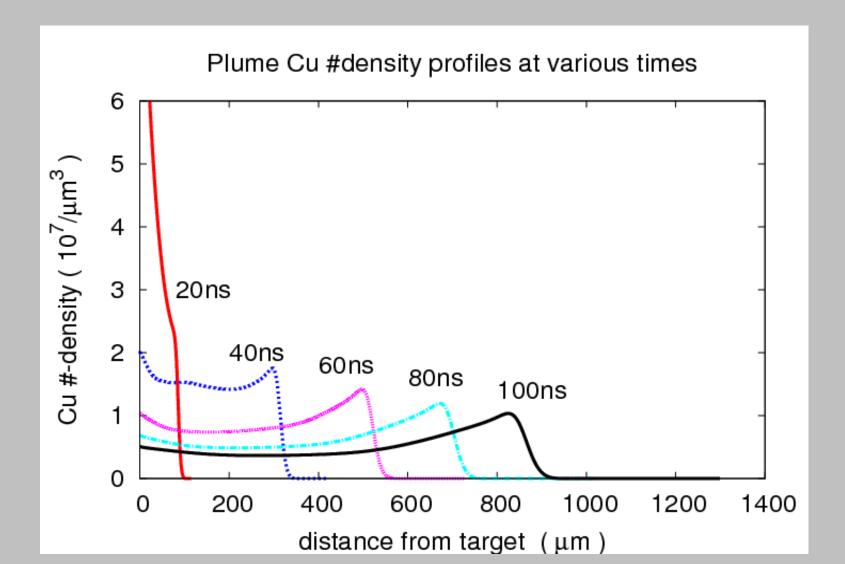
1-D simulation

max plume **Pressure** ~ 220 MPa (~ 2200 atm)



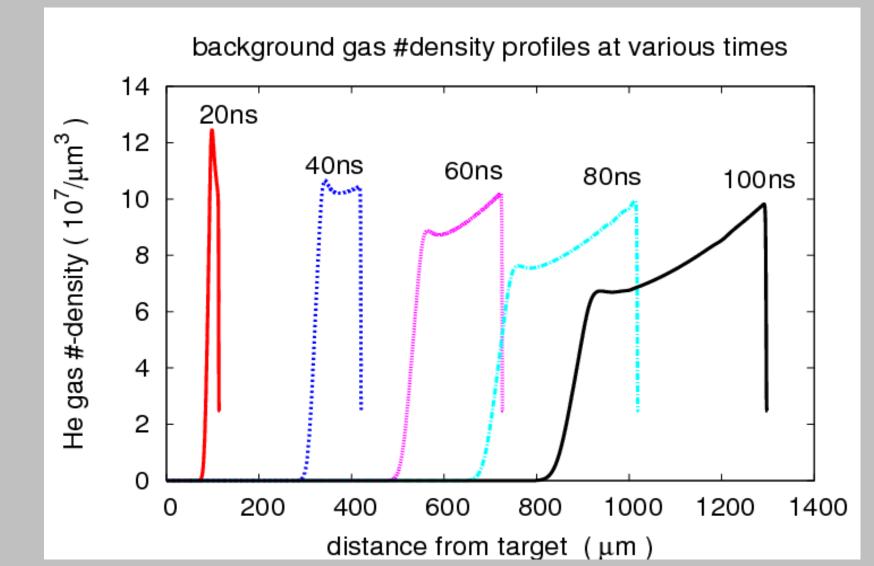
1-D simulation

Peak Copper vapor Number-density ~ 27.10²⁵/m³



1-D simulation

Peak He gas number-density ~ 12.10²⁵/m³



Current and future developments

- Bubble formation (Volmer-Döring theory)
- explosive boiling near critical T (Eötvös rule) (has major effect on melt depth due to shielding by plasma)
- Two Temperatures in plasma, for ions and electrons
- Inverse Bremsstrahlung and multi-photon ionization

Future

•fs (femptosecond) laser: all the above features and more

- extend to 2D (axisymmetric), and later to 3D
- coupling to electric field in target to model thermionic emission and Coulomb explosion
- Particle formation by recondensation and transport in 2D, 3D

Particle formation by condensation

